Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/073,850	LI ET AL.	
Examiner	Art Unit	
I Derek Butten	2102	

SEARCHED					
Class	Subclass	Date	Examiner		
717	105,125, 127	5/19/2006	JDR		
715	767 771	5/19/2006	JDR		
715	854	5/19/2006	JDR		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
717	105, 125	5/19/2006	JDR		
717	127	5/19/2006	JDR		
715	767, 771	5/19/2006	JDR		
715	/854	5/19/2006	JDR		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB; DERWENT) - see search history printout	5/11/2006	JDR
Antony Nguyen-Ba (re. allowable subject matter)	5/11/2006	JDR
717/105,125; 715/764,771,853,854 - Text search only - see search notes printout	5/11/2006	JDR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB; DERWENT) - see search history printout	5/12/2006	JDR
ACM - portal.acm.org IEEE - ieeexplore.ieee.org See search history printout	5/12/2006	JDR